

# United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/098,688	03/15/2002	Shunpei Yamazaki	SEL 308	5173	
75	90 12/13/2005		EXAM	INER	
COOK, ALEX, MCFARRON, MANZO,			CHEN, BRET P		
Suite 2850	MEHLER, LTD.		ART UNIT PAPER NUMBE		
200 West Adams St.			1762		
Chicago, IL 60	0606		DATE MAILED: 12/13/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	
	10/098,688	YAMAZAKI ET AL	
Office Action Summary	Examiner	Art Unit	
	B. Chen	1762	
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence ad	dress
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period w  - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim rill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	N. nely filed the mailing date of this co D (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on  2a) This action is FINAL. 2b) This  3) Since this application is in condition for allowar closed in accordance with the practice under E	action is non-final. nce except for formal matters, pro		merits is
Disposition of Claims			
4) Claim(s) 46-110 is/are pending in the application 4a) Of the above claim(s) is/are withdraw 5) Claim(s) 58-73,77-80,84-87,100-103 and 107-16) Claim(s) 46-57,74-76,81-83,88-99 and 104-106 7) Claim(s) is/are objected to.  8) Claim(s) are subject to restriction and/or Application Papers  9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) access Applicant may not request that any objection to the or Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Examine 11) The oath or declaration is objected to by the Examine 11) The oath or declaration is objected to by the Examine 11) The oath or declaration is objected to by the Examine 11)	vn from consideration.  110 is/are allowed.  is/are rejected.  relection requirement.  r.  epted or b) objected to by the force and the control of the drawing(s) be held in abeyance. Section is required if the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to by the force are the control of the drawing(s) is objected to be are the control of the drawing(s).	e 37 CFR 1.85(a). ected to. See 37 CF	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list of	s have been received. s have been received in Applicati ity documents have been receive (PCT Rule 17.2(a)).	on No ed in this National	Stage
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	ite	-152)

Art Unit: 1762

#### **DETAILED ACTION**

Claims 46-110 are pending in this application.

## Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 50-57, 75-76, 82-83, 88-96, 98-99, 105-106 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention.

In claim 50, the limitation of "the heat generating means is covered with said heat absorber" is deemed new matter as there appears to be no support for such a limitation in the original specification. It is noted that the absorber is discussed on p.5 lines 4-8 and p.24 lines 2-11 but not the newly added limitation. The same issue is applied to claims 51-53, 75, 82, 89, 95, 98, 105 as well as claims 54-57, 76, 83, 90, 96, 99, 106.

In claim 88, the limitation of the gas flowing "through pores of an orifice plate over the substrate" is deemed new matter as there appears to be no support for such a limitation in the original specification. It is noted that there is mention of orifice plates 1106 and 1107 on pp.14-15 but no support for the claimed limitations. The same issue applies to 89-94.

Application/Control Number: 10/098,688 Page 3

Art Unit: 1762

## Claim Rejections - 35 USC § 103

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claims 46-57, 74-76, 81-83, 88-90, 95-99, 104-106 are rejected under 35 U.S.C.

103(a) as being unpatentable over Hemsath et al. (5,997,286). Hemsath discloses a thermal treating process with a recirculation plenum (col.5 lines 4-13) in which the plenum 30 introduces a stream at the upstream end 31 and is in fluid communication with a downstream end 26 (col.7 line 64 – col.8 line 8). The fluid is recirculated (col.8 lines 8-36). A heater can be utilized (lines 17-21), as well as a heat exchanger and coolers (lines 21-23). The fluid can be an oxidizing gas or a non-oxidizing gas and a second chamber can be utilized (col.12 lines 21-29). A semiconductor film is taught in col.2 lines 23-57 as well as a orifice plate (col.9 lines 17-54). However, the reference remains silent on the location of the heating means.

It is noted that the reference utilizes the heating means to heat the fluid and the substrate as noted above. One skilled in the art would realize that the location of the heating means is irrelevant as long as it heats. It would have been obvious to one skilled in the art to place the heating means in the upstream side of the chamber with the expectation of obtaining equivalent results and in the absence of a showing of unexpected results.

The limitations of claims 46-57, 74-67, 88-90 have been addressed above.

In claims 81-83, the applicant requires a gas flow perpendicular to the substrate. The reference clearly teaches of flowing a gas over the substrate. To flow the gas perpendicular would have been obvious with the expectation of obtaining similar results.

Application/Control Number: 10/098,688 Page 4

Art Unit: 1762

Claims 46-57, 74-76, 81-83, 88-90, 95-99, 104-106 are rejected under 35 U.S.C.

103(a) as being unpatentable over Ushikawa (5,378,283). Ushikawa discloses a method of using a heat treating device which can maintain ambient atmosphere of inert gas in the load lock chamber at high purity with a minimum feed amount of the inert gas into the load lock chamber, and which is useful to suppress generation of particles and prevent chemical contamination (col.3 lines 29-35). Gases are disposed on an upstream side 5 and exhausted on a downstream side 4 (col.1 lines 30-35) and subsequently recirculated (col.3 lines 50-68). The gas is heated by heater 2 and can be oxygen or nitrogen (col.2 lines 1-6). However, the reference fails to specifically teach heating a substrate.

It is noted that the reference does teach a heating temperature of 500-1000°C (col.7 lines 36-39). One skilled in the art would realize that the temperature of the substrate would be heated by having this heating temperature. Hence, it would have been obvious to heat the substrate given Ushikawa's teaching of a heated atmosphere with the expectation of maintaining better temperature control of the substrate.

The limitations of 47-57, 74-76, 81-83, 88-90, 95-99, 104-106 have been addressed above.

### Allowable Subject Matter

Claims 58-73, 77-80, 84-87, 100-103, 107-110 are allowed. It should be noted that the allowability of claims 91-94 have been withdrawn due to the new matter rejection.

Art Unit: 1762

Any inquiry concerning this communication or earlier communications from the examiner should be directed to B. Chen whose telephone number is (571) 272-1417. The examiner can normally be reached on 7:30am - 4:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Timothy Meeks can be reached on (571) 272-1423. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Bc 3/20/05

BRET CHEN
PRIMARY EXAMINER